## Bismuth tri-iodide - Graphene 2D material

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A plethora of 2D materials has been studied during the last years, composed by one or a few layers of the same element, the same compound or more than one compound. Although several of them are in a well developed stage, new 2D materials emerge. Among them, Bismuth tri-iodide–Graphene have been reported a few times (theoretical and experimental results). and exhibits interesting properties. Although it has been applied as radiation detector, these predictions and results foresee photovoltaic applications for BiI<sub>3</sub> layers and van der Waals superstructures. Also, theoretical studies predict stable BiI<sub>3</sub>—graphene heterostructures, with higher absorption for visible light photons related to BiI<sub>3</sub> monolayers. Within this framework, this work investigates the growth of van der Waals superstructures BiI<sub>3</sub>—graphene.

BiI<sub>3</sub>-Graphene 2D layers were obtained by physical vapor transport from BiI<sub>3</sub> (Aldrich 99,999%) nucleation and further growth, onto graphene covered TEM grids (single layer graphene film on a 2,5 μm holey silicon nitride film, Ted Pella), and onto 1 layer graphene film/200nm SiO<sub>2</sub> film on a 675 μm ultra-flat silicon substrates, 5×5 mm, Ted Pella. The growth was performed in an especially built equipment, varying initial pressure (10<sup>-6</sup>–10<sup>-7</sup> mBar), BiI<sub>3</sub> mass (6-80 mg), source (260.2 °C) and substrate (40±1 °C) temperature (and then supersaturation), and deposition time (10-120 s), with a source-substrate distance of 15.0±0.5 mm), under high purity Ar atmosphere. Layers were characterized by High Resolution Transmission Electron Microscopy (HR-TEM), Fast Fourier Transform (FFT), Energy Dispersive Spectroscopy (EDS), Scanning Electron Microscopy - Field Emission Gun (SEM-FEG), Atomic Force Microscopy (AFM) and Gracing Incidence X-Ray Diffraction (GIXRD) and X-ray Reflectometry (XRR).

Twisted BiI<sub>3</sub> layers which determine Moiré interference were obtained, indicating BiI<sub>3</sub>-graphene van der Waals superstructures with two or more BiI<sub>3</sub> layers. It was not possible by now to obtain an uniform coverage of the substrate, but this kind of superstructure cover all the grid. In our knowledge, this is the first report of Moiré interference for BiI<sub>3</sub> layers, and it is similar to the interference reported for graphene and for other van der Waals superstructures (WS<sub>2</sub>-gr, MoS<sub>2</sub>-gr). Furthermore, Moiré diagrams indicate that the angle between layers is not constant. EDS measurements show BiI<sub>3</sub> as the layer composition, and FFTs show that the orientation of the layers was always with c axis perpendicular to the substrate, while BiI<sub>3</sub> is always present in its rhombohedral phase R-3.

GIXRD confirms layer composition as BiI<sub>3</sub> in agreement with EDS results, the rhombohedral phase R-3 (data correlated with file 00-048-1795 PDF4+ 2021 database and with powdered BiI<sub>3</sub>, in agreement with HR-TEM results, and the orientation of the BiI<sub>3</sub> layers with the *c* axis perpendicular to the substrate, which agrees with HR-TEM results as well. According to XRR, the BiI<sub>3</sub> layer exhibits a density of 6.0 g/cm<sup>3</sup> (BiI<sub>3</sub> bulk 5.8 g/cm<sup>3</sup>), a thickness of 34.6 nm, which gives approximately 16 BiI<sub>3</sub> layers (c= 20.72 Å), and a roughness of 6.0 nm, approximately 3-4 BiI<sub>3</sub> layers.

The obtained BiI<sub>3</sub>-graphene superstructure is similar to structures of TMDs-graphene (as MoS<sub>2</sub>-graphene), and is stable, as was theoretically predicted.